

Image



PATENT
Customer No. 22,852
Attorney Docket No. 07553.0029-00000

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Masaaki HAGIHARA et al.)	Group Art Unit: 1763
)	
Application No.: 10/030,656)	Examiner: A. Olsen
)	
Filed: January 11, 2002)	
)	
For: ETCHING METHOD AND)	
PLASMA PROCESSING)	
METHOD)	

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

SUPPLEMENTAL AMENDMENT

Applicants timely filed a *bona fide* Amendment responsive to the Office Action mailed August 26, 2003, on January 26, 2004, along with a petition for a two-month extension of time and appropriate fee payment. Applicants respectfully request that the Examiner consider this Supplemental Amendment.

Please amend the above-identified application as follows:

Please amend the claims as set forth in the Amendments to the Claims section.

The **Amendments to the Claims** section begins on page 2 of this Amendment.

Remarks begin on page 10 of this Amendment.